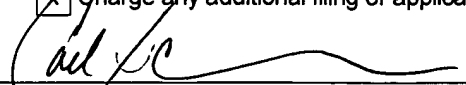


IFW

| AMENDMENT TRANSMITTAL LETTER | | | | Docket No. ISH-0227 | |
|--|---|---|-----------------------------------|--------------------------------|------|
| Application No. 10/523,976-Conf. #1124 | | Filing Date February 8, 2005 | | Examiner M. T. Rachuba | |
| | | | | Art Unit 3723 | |
| Applicant(s): Toshihiro TSUCHIYA | | | | | |
| Invention: WAFER POLISHING METHOD AND APPARATUS | | | | | |
| TO THE COMMISSIONER FOR PATENTS | | | | | |
| Transmitted herewith is an amendment in the above-identified application. | | | | | |
| The fee has been calculated and is transmitted as shown below. | | | | | |
| CLAIMS AS AMENDED | | | | | |
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | |
| Total Claims | 5 | - 20 = | 0 | x 50.00 | 0.00 |
| Independent Claims | 3 | - 3 = | 0 | x 200.00 | 0.00 |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | |
| Other fee (please specify): | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 0.00 |
| <input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity | | | | | |
| <input checked="" type="checkbox"/> No additional fee is required for this amendment. | | | | | |
| <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed. | | | | | |
| <input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed. | | | | | |
| <input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached. | | | | | |
| <input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed. | | | | | |
| <input checked="" type="checkbox"/> Credit any overpayment. | | | | | |
| <input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17. | | | | | |
|  David T. Nikaido Attorney/Agent Reg. No.: 22,663 | | | | Dated: <u>January 26, 2007</u> | |
| Carl Schaukowitch Attorney/Agent Reg. No.: 29,211 RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750 | | | | | |



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Toshihiro TSUCHIYA

Application No.: 10/523,976

Filed: February 8, 2005

For: WAFER POLISHING METHOD AND APPARATUS

Attorney Docket No.: ISH-0227

Examiner: M. T. Rachuba

Art Unit: 3723

Confirmation No.: 1124

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

I. INTRODUCTORY COMMENTS

In response to the Office Action dated November 7, 2006, please amend the above-identified application as set forth below.

Claims 1-5 are pending in the application. By this Amendment, claims 6-8 are canceled without prejudice or disclaimer and claims 1-3 are amended.

Applicants express their appreciation for the Examiner's indication of allowable subject matter in claims 2 and 3. Claims 2 and 3 are amended in a manner which places them in condition for allowance.

II. AMENDMENTS TO THE DRAWINGS

(There are no amendments to the drawings)

III. AMENDMENTS TO THE SPECIFICATION

(There are no amendments to the specification)